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AC 05/01  
503.30414V18  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): KATO, et al.

Serial No.: 09/614,764

Filed: July 12, 2000

For: VACUUM PROCESSING APPARATUS AND OPERATING  
METHOD THEREFOR

Group: 3749

Examiner: S. Gravini

Allowed: October 13, 2000

Batch No.: T69

AMENDMENT UNDER 37 CFR 1.312

Assistant Commissioner for Patents

Box Issue Fee

Washington, D.C. 20231

November 28, 2000

Sir:

Subsequent to issuance of the Notice of Allowance mailed  
October 13, 2000, please amend the above-identified  
application as follows:

IN THE CLAIMS

Please amend the claims presently in the application as  
follows:

- Sub C'*
- 
1. (Amended) A method of transferring a substrate,  
using an apparatus comprising  
a cassette for receiving plural substrates in air;  
an atmospheric transferring device for transferring,  
one by one, said substrates;  
a vacuum transferring chamber having a vacuum

match  
return